

Application/Control No.	Applicant(s)/Patent under Reexamination

KAI

KAMIYAMA ET AL.

Art Unit

10/582,158 Examiner

Noah Kamen

3747

SEARCHED					
Class	Subclass	Date	Examiner		
search	updated	7/18/2007	X		
			!		

INTERFERENCE SEARCHED					
Subclass	Date	Examiner			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
		,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,		
,				
	1)			
	•			